

Notice of References Cited

Application/Control No.

10/581,589

Applicant(s)/Patent Under
Reexamination
KOYAMA, RIKI

Examiner

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Art Unit

3744

Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,584,439 B1	06-2003	Geilhufe et al.	704/270
*	B	US-7,505,909 B2	03-2009	Koyama, Rika	704/275
	C	US-			
	D	US-			
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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